Dkt. 2271/65887-Z

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Shunichi SATO et al.

Serial No. : Divisional of 09/957,507

Filed : Herewith

For : VERTICAL-CAVITY, SURFACE-EMISSION TYPE LASER DIODE AND FABRICATION PROCESS THEREOF

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Commissioner for Patents
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Sir:

PRELIMINARY AMENDMENT TO THE ACCOMPANYING DIVISIONAL APPLICATION FILED UNDER 37 C.F.R. §1.53(b)

This Preliminary Amendment is being submitted concurrently with the above-identified patent application.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the claims are reflected in the Listing of Claims section which begins on page 3.

Remarks begin on page 5 of this paper.